

PTO-1449	Application No.	Applicant(s)	
	09/746,822	Islam, et al.	
Information Disclosure Citation in an Application	Docket Number	Group Art Unit	Filing Date
	068069.0110		12/22/2000

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PAT & TRADEMARK		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
HP	A	4,011,009	03/08/77	Lama, et al.	350	162 R	05/27/75
HP	B	4,900,119	02/13/90	Hill, et al.	350	96.15	04/01/88
HP	C	5,212,743	05/18/93	Heismann	385	11	02/12/92
HP	D	5,311,360	05/10/94	Bloom, et al.	359	572	04/28/92
HP	E	5,459,610	10/17/95	Bloom, et al.	359	572	05/20/93
HP	F	5,500,761	03/19/96	Goossen, et al.	359	290	01/27/94
HP	G	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95
HP	H	5,659,418	08/19/97	Yurke	359	290	02/05/96
HP	I	5,661,592	08/26/97	Bornstein, et al.	359	291	01/07/95
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HP	K	5,745,271	04/28/98	Ford, et al.	359	130	07/31/96
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HP	M	5,825,528	10/20/98	Goossen	359	291	12/26/95
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HP	Q K. E. Petersen, "Micromechanical Light Modulator Array Fabricated On Silicon," Applied Physics Letters, Vol. 31, No. 8, pp. 521-523	10/15/77
HP	R C. Marxer, et al., "Megahertz Opto-Mechanical Modulator," Elsevier Science S.A., pp. 46-50	1996
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HP	W O. Solgaard, et al., "Deformable Grating Optical Modulator," Optics Letters, Vol. 17, No. 9, pp. 688-690	05/01/92
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HP	D	5,943,155	08/24/99	Goossen	359	247	08/12/98
HP	E	5,943,158	08/24/99	Ford, et al.	359	295	05/05/98
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HP	T	D. M. Burns, et al., "Micro-Electro-Mechanical Variable Blaze Gratings," IEEE 10th Annual International Workshop on Micro Mechanical Systems, pp. 385-391					1997
HP	U	L. Y. Lin, et al., "Micromachined polarization-state controller and its application to polarization-mode dispersion compensation," OFC 2000, Baltimore, MD, pp. ThQ3-1, 244-246					2000
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HP	W	R.W. Corrigan, et al., "17.3: Calibration of a Scanned Linear Grating Light Value™ Projection System," www.siliconlight.com					1999
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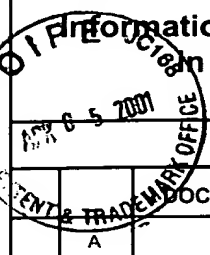
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HP	M	M. Ming, et al., "Principles and Applications of Optical Communications," Irwin, pp. 468 & 470	1996
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